



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Kiyoshi IRINO et al.**

Group Art Unit: **2815**

Serial No.: **09/428,052**

Examiner: **Jose R. Diaz**

Filed: **October 27, 1999**

Confirmation No.: **4139**

For: **METHOD OF FABRICATING A SEMICONDUCTOR DEVICE
CONTAINING NITROGEN IN A GATE-OXIDE FILM (AS
AMENDED)**

Attorney Docket Number: **970901A**

Customer Number: **38834**

AMENDMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Date: August 1, 2005

Sir:

This paper is filed in response to the Office Action dated May 5, 2005.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 4 of this paper.